

1752
AF\$

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#13

In re application of

Kenichiro SATO, et al.



Appln. No.: 09/541,597

Group Art Unit: 1752

Confirmation No.: Unknown

Examiner: R. ASHTON

Filed: April 3, 2000

For: POSITIVE PHOTORESIST COMPOSITION FOR FAR UNTRAVIOLET EXPOSURE

NOTICE OF APPEAL

Commissioner for Patents
Washington, D.C. 20231

RECEIVED
DEC 27 2001
TC 1700

Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the final Office Action dated July 23, 2001.

A check for the statutory fee of \$320.00 is attached. Please charge or credit any difference or overpayment to Deposit Account No. 19-4880. A duplicate copy of this sheet is enclosed.

12/25/2001 TGEDAHU1 00000048 09541597

01-70-119

~~320.00 OF~~

Respectfully submitted,

Lee C. Wright
Registration No. 41,441

SUGHRUE MION, PLLC
2100 Pennsylvania Avenue, N.W.
Washington, D.C. 20037-3213
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

Date: December 21, 2001